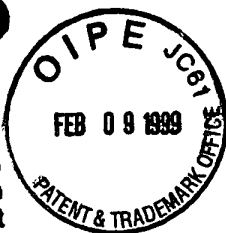


CERTIFICATE OF MAILING

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Richard B. Hunt



- 1 -

Docket: 0756-1799

5/B
2-24-99
pc

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT Application of)

Mitsunori SAKAMA)

Serial No. 09/070,908)

Filed: May 4, 1998)

For: FILM FORMING METHOD AND)

FILM FORMING APPARATUS)

RECEIVED

FEB 23 1999

) Art Unit: 1762

) Examiner: M. Padgett

GROUP 1700

) Date: February 5, 1999

AMENDMENT

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action of November 5, 1998, please amend the subject application as follows:

IN THE CLAIMS:

Please cancel claims 1-15 and ~~20-22~~ and add new claims 23-50 as follows:

B1

Sub D1

23. A film forming method comprising:
a first step of supplying a hydrogen gas into a chamber;

02/17/1999 MMARMOL 00000060 09070908

01 FC:102
02 FC:103

156.00 OP
108.00 OP